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Advanced Optical Manufacturing and Metrology Technologies

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Contents

ADVANCED OPTICAL MANUFACTURING AND METROLOGY TECHNOLOGIES

| | |
|----------|---|
| 12071 02 | Research on active fluid jet polishing process with revolution and rotation pin [12071-3] |
| 12071 03 | Robot-assisted rotation-revolution belt grinding of cylinder optical element [12071-33] |
| 12071 04 | Structure design and performance analysis of double piezoelectric ceramic drive fast tool servo system [12071-35] |
| 12071 05 | Simulation analysis of internal stress of plastic molded lens [12071-63] |
| 12071 06 | Study on the stress field characteristics of single crystal silicon irradiated by composite high-energy pulsed laser [12071-26] |
| 12071 07 | Research of thin film damage testing based on photothermal deflection [12071-57] |
| 12071 08 | Optical surface error analysis and compensation technique based on Zernike polynomial coefficients [12071-47] |
| 12071 09 | Research on the optimization design of the edge reducing for the negative blended lenticulars with high myopic astigmatism [12071-31] |
| 12071 0A | Simulation and application of spherical tool influence function for magnetorheological finishing [12071-6] |
| 12071 0B | A prediction algorithm for the smoothing process of large-aperture optical components with complex periodic middle-spatial frequency errors [12071-70] |
| 12071 0C | The development of six-channel quantitative real-time PCR filter sets for nucleic acid detection [12071-50] |
| 12071 0D | Investigation on surface figure control technology of medium-aperture optical component based on double-sided polishing [12071-68] |
| 12071 0E | Modulation transfer function measurement method based on dynamic initial value fitting [12071-19] |
| 12071 0F | Design of interferometer system with common optical path structure [12071-10] |
| 12071 0G | Study on the self-calibration technology used in large diameter and long focal length collimator [12071-37] |
| 12071 0H | Ultra-precision grinding and accuracy measurement of the hard-brittle thin-walled tubular optics [12071-20] |

| | |
|----------|---|
| 12071 0I | Measurement to local phase modulation of LCSLM using multi-region synchronous processing of carrier interference fringe [12071-60] |
| 12071 0J | Circular fringe center location based on local gradient direction estimation [12071-21] |
| 12071 0K | Correction of wavelength error of white-light interference phase-shifting algorithm [12071-66] |
| 12071 0L | Investigation of wheel polishing technology based on industrial robot [12071-77] |
| 12071 0M | Research on grinding performance of micro-structured CVD diamond wheel for BK7 optical glass [12071-41] |
| 12071 0N | Fizeau interferometry with computer generated hologram for mid-spatial wavefront measurement of lens with long focal length [12071-61] |
| 12071 0O | Speckle noise suppression of digital holographic microscopy with diffusion glass rotation [12071-74] |
| 12071 0P | Image enhancement of Shack-Hartmann wavefront sensor with non-uniform illumination [12071-45] |
| 12071 0Q | A new optical polarizing prism extinction ratio measurement method based on heterodyne-detecting [12071-65] |
| 12071 0R | Study on combined manufacturing technology for high precision silicon aspherical optics [12071-40] |
| 12071 0S | Design of a line-scanning dispersive objective lens for chromatic confocal displacement sensor [12071-43] |
| 12071 0T | Machining approach of freeform optics via fast tool servo diamond turning [12071-46] |
| 12071 0U | An investigation of error compensation for a 6-DoF industrial robot based on neural network and stiffness modelling [12071-13] |
| 12071 0V | A study on the laser-assisted cutting of single crystal Si for optimal machining [12071-78] |
| 12071 0W | The research on optical free-form metrology technologies [12071-69] |
| 12071 0X | Figure error of optical elements induced aberrations of optical system [12071-53] |
| 12071 0Y | Overview of environment simulation device for large aperture optical imaging quality test [12071-72] |
| 12071 0Z | Research on surface profile measurement of weak-rigid plate [12071-52] |
| 12071 10 | Optical mirror surface shape on-site measurement based on reverse Hartmann test [12071-22] |
| 12071 11 | In-situ measurement technology of robotic polishing system [12071-51] |

- 12071 12 **The influence of pressure groove on micro jet machining [12071-36]**
- 12071 13 **Thermal deformation suppression method for chalcogenide glass based on deep cryogenic treatment [12071-17]**
- 12071 14 **Synchronous microdeformation and first derivative dynamic measurement based on laser shearing speckle interferometry [12071-25]**

